



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki HASHIMOTO

Group Art Unit: 2822

Application No.: 09/856,627

Examiner:

I. Soward

Filed: May 24, 2001

Docket No.:

109609

For:

INTERCONNECT SUBSTRATE, SEMICONDUCTOR DEVICE, METHOD OF FABRICATING, INSPECTING AND MOUNTING THE SEMICONDUCTOR

DEVICE, CIRCUIT BOARD, AND ELECTRONIC INSTRUMENT

AMENDMENT UNDER 37 C.F.R. §1.111

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

In reply to the Office Action mailed April 4, 2003, please amend the above-internal contraction of the U.S. Patent and Traucation, D.C. 20231

In reply to the Office Action mailed April 4, 2003, please amend the above-internal contraction of the U.S. Patent and Traucation, D.C. 20231 application as follows:

Remarks.